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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#16
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5/3/03

In re Application of:)
HIROKATSU MIYATA) : Examiner: Hai Vo
Application No.: 09/657,616) : Group Art Unit: 1771
Filed: September 8, 2000) :
For: MESOSTRUCTURED THIN FILM,)
MESOPOROUS THIN FILM, AND)
PROCESS FOR PRODUCTION)
THEREOF : April 24, 2003

Commissioner for Patents
Washington, D.C. 20231

AMENDMENT

Sir:

In response to the final Office Action dated December 24, 2002 and the
Advisory Action dated April 7, 2003, kindly amend the subject application as follows.

05/01/2003 GWORD01 00000079 09657616

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168.00 OP

I hereby certify that this correspondence is being deposited with the
United States Postal Service as first-class mail in an envelope addressed
to: Commissioner for Patents, Washington, D.C. 20231 on

April 24, 2003

(Date of Deposit)

PETER SAXON (24947)

(Name of Attorney for Applicant)

Signature

April 24, 2003

Date of Signature